In

OIPE 423

Invention: SEMICONDUCTOR DEVICE AND METHOD FOR MANUFACTURING THE SAME

MS Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Transmitted herewith is an amendment in the above-identified application.

The fee has been calculated and is transmitted as shown below.

CLAIMS AS AMENDED						
	Claims Remaining After Amendment	Highest Number Previously Pald	Number Extra Claims Present		Rate	
Total Claims	13	- 20 =	0	X	50.00	0.00
ndependent Claims	3	- 3 =	0	x	200.00	0.00
Multiple Depend	lent Claims (ch	eck if applicable	e)			
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1///	1/1/2	A-			Dated: Se	eptember 8, 2006
Michael R. Can Attorney Reg. N		-				
BIRCH, STEWA B110 Gatehous Suite 100 East P.O. Box 747 Falls Church, V (703) 205-8000	e Road irginia 22040-		_P			



Docket No.: 0649-0901P

(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Takeshi MISAWA

Application No.: 10/620,461

Confirmation No.: 9184

Filed: July 17, 2003

Art Unit: 2811

For: SEMICONDUCTOR DEVICE AND METHOD

FOR MANUFACTURING THE SAME

Examiner: Kang, Donghee

AMENDMENT IN RESPONSE TO NON-FINAL OFFICE ACTION

MS Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated February 21, 2006, please amend the above-identified U.S. patent application as follows:

Amended Claim Set; and

Remarks.